



Contribution ID: 68

Type: **Poster**

Large area small pitch gratings for x-ray interferometry by Displacement Talbot lithography

Wednesday 13 September 2017 12:30 (2 hours)

Author: Dr JEFIMOV, Konstantins (Paul Scherrer Institut)

Co-authors: Dr DAIS, Christian (Eulitha AG); Dr SOLAK, Harun (Eulitha AG); Dr VILA-COMAMALA, Joan (Institute for Biomedical Engineering); Dr WANG, Li (Eulitha AG); Prof. ROMANO, Lucia (PSI); STAMPANONI, Marco (Paul Scherrer Institut); KAGIAS, Matias (Paul Scherrer Institut); Dr WANG, Zhentian (PSI)

Presenter: Dr JEFIMOV, Konstantins (Paul Scherrer Institut)

Session Classification: Lunch break & Poster session

Track Classification: Fabrication Methods